

**Notice of References Cited**

Application/Control No.

10/052,549

Applicant(s)/Patent Under Reexamination  
EBINA ET AL.

Examiner

Marcos D. Pizarro-Crespo

Art Unit

2814

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0168813	11-2002	Ogura	438/200
	B	US-4,372,031	02-1983	Tsaur et al.	438/257
	C	US-6,091,101	07-2000	Wang, Ling-Sung	257/315
	D	US-6,248,633	06-2001	Ogura et al.	438/267
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.